

10/089092

IC13 Rec'd PCT/PTO 12 APR 2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of)
Stefan CRAMER et al)
Appln. No. : TBA)
Filed : April 12, 2002)
For : METHOD FOR INCREASING THE)
INTERFERENCE RESISTANCE OF A TIME)
FRAME REFLECTOMETER AND A)
CIRCUIT DEVICE FOR IMPLEMENTING)
SAID METHOD)

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5/13/03
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INFORMATION DISCLOSURE STATEMENT

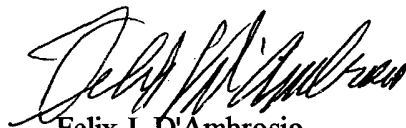
Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

Pursuant to the provisions of 37 CFR 1.97 and 1.98, submitted herewith are copies
of the art cited in the International Search Report.

The presentation of these documents is made solely for the purpose of giving the
Patent and Trademark Office Examiner an opportunity to make an independent review of the
disclosure of the present application in the course of his examination. No representation of any nature
is made or intended by this presentation.

Respectfully submitted,



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April 12, 2002

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FORM PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET NO.	SERIAL NO. TRA
	APPLICANT: Stephen CRAMER et al	
	FILING DATE April 12, 2002	GROUP

REFERENCES DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE
	AA	5,609,059	03/11/97	McEwan			
	AB	5,563,605	10/08/96	McEwan			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATED Y N
	AL	EP0780665A2	06/25/97	Europe			
	AM	EP0780665A3	11/11/98	Europe			
	AN	EP0875772A2	11/04/98	Europe			
	AO	1815752	06/25/70	Germany			
	AP	DE29815069U1	02/11/99	Germany			

OTHER ART (including Author, Title, Pertinent Pages, etc.)

	AR		
	AS		
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EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.